

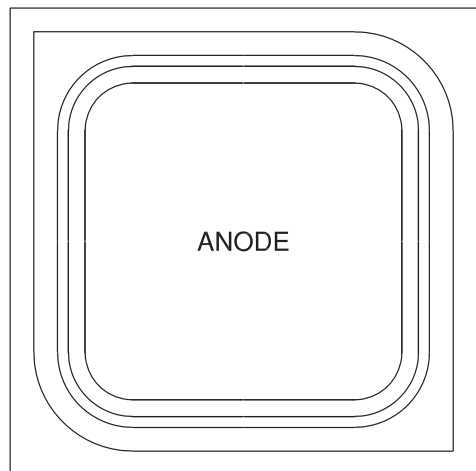
PROCESS CPD87R
Schottky Diode
Low Leakage Schottky Diode Chip



PROCESS DETAILS

Process	EPITAXIAL PLANAR
Die Size	14.6 x 14.6 MILS
Die Thickness	3.9 MILS
Anode Bonding Pad Area	11.8 x 11.8 MILS
Top Side Metalization	Al - 30,000Å
Back Side Metalization	Au - 12,000Å

GEOMETRY



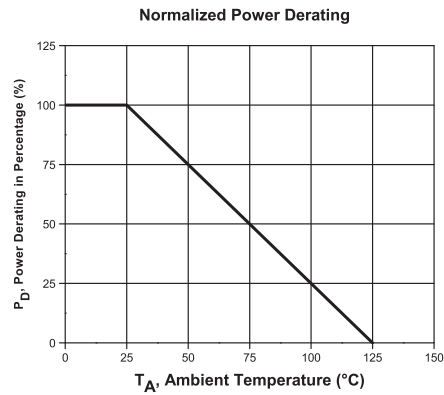
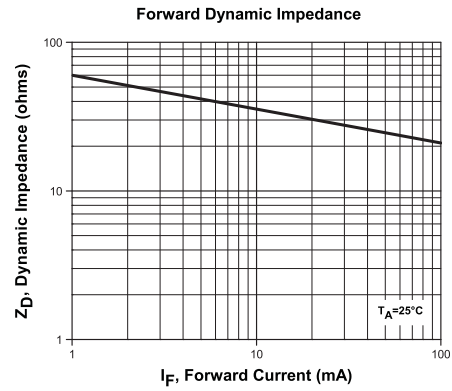
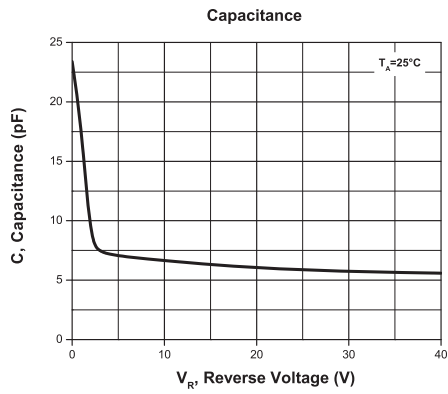
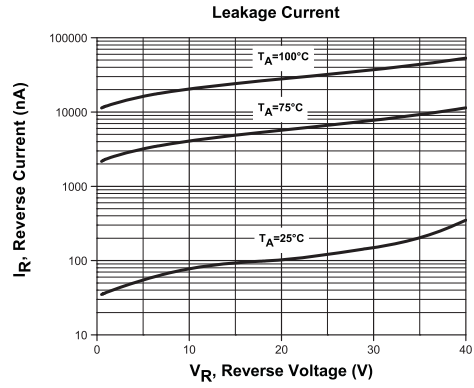
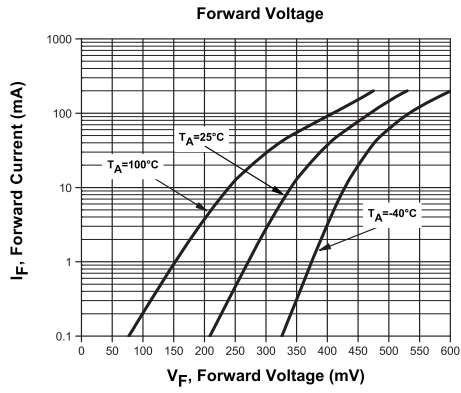
GROSS DIE PER 5 INCH WAFER
80,698

PRINCIPAL DEVICE TYPES
CFSH2-4L

R1 (22-March 2010)

PROCESS CPD87R

Typical Electrical Characteristics



R1 (22-March 2010)